



Attorney Docket No. 51876.P542

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Patent Application of:

Tae-Woo Jung et al.

Serial No. 10/750,021

Filed: December 30, 2003

For: **METHOD FOR FABRICATING
SEMICONDUCTOR DEVICE HAVING
TRENCH TYPE DEVICE ISOLATION
LAYER**

Examiner: Quovaunda Jefferson

Art Unit: 2823

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

AMENDMENT AND RESPONSE TO FINAL OFFICE ACTION

Dear Commissioner:

In response to the Final Office Action mailed May 17, 2005, regarding the above-referenced application, Applicant respectfully requests entry of the amendment set forth below in consideration of the remarks that follow.

DO NOT ENTER 7/20/2006 QVJ